International

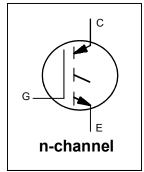
 $V_{CES} = 1200V$ $I_{C(Nominal)} = 30A$ $T_{J(max)} = 175^{\circ}C$ $V_{CE(on)}$ typ = 1.69V @ I_{C} = 30A

Applications

- Medium Power Drives
- UPS
- HEV Inverter
- Welding
- Induction Heating



IRG7CH42UEF



G	С	Е	
Gate	Collector	Emitter	

Features	► Benefits
	High efficiency in a wide range of applications and switching frequencies
	Improved Reliability due to rugged hard switching performance and higher power capability
Positive V _{CE (ON)} Temperature Coefficient	Excellent current sharing in parallel operation

Bass port number	Deekege Ture	Standa	rd Pack	Orderable part number	
Base part number	Package Type	Form	Quantity		
IRG7CH42UEF	Die on film	Wafer	1	IRG7CH42UEF	

Mechanical Parameter

Die Size	4.699 x 6.35	mm ²		
Minimum Street Width	75	μm		
Emiter Pad Size (Included Gate Pad)	See Die Drawing			
Gate Pad Size	0.503 x 0.501	mm ²		
Area Total / Active	29.84/17.74			
Thickness	120	μm		
Wafer Size	200	mm		
Flat Position	0	Degrees		
Maximum-Possible Chips per Wafer	914 pcs			
Passivation Front side	Silicon Nitride			
Front Metal	Al, Si (4µm)			
Backside Metal	Al- Ti - Ni- Ag (1kA°-1kA°-4kA°-6kA°)			
Die Bond	Electrically conductive epoxy or solder			
Reject Ink Dot Size	0.25 mm diameter minimum			

Maximum Ratings

	Parameter	Max.	Units
V _{CE}	Collector-Emitter Voltage, TJ=25°C	1200	V
I _C	DC Collector Current	0	А
I _{LM}	Clamped Inductive Load Current ②	120	А
V _{GE}	Gate Emitter Voltage	± 30	V
T _J , T _{STG}	Operating Junction and Storage Temperature	-40 to +175	°C

Static Characteristics (Tested on wafers) . TJ=25°C

	Parameter	Min.	Тур.	Max.	Units	Conditions
V _{(BR)CES}	Collector-to-Emitter Breakdown Voltage	1200				V _{GE} = 0V, I _C = 100µA ③
V _{CE(sat)}	Collector-to-Emitter Saturated Voltage		1.17	1.40	V	V _{GE} = 15V, I _C = 5A, T _J = 25°C
V _{GE(th)}	Gate-Emitter Threshold Voltage	3.0		6.0		$I_{C} = 1 \text{mA}$, $V_{GE} = V_{CE}$
I _{CES}	Zero Gate Voltage Collector Current		1.0	150	μA	V _{CE} = 1200V, V _{GE} = 0V
I _{GES}	Gate Emitter Leakage Current			± 100	nA	$V_{CE} = 0V, V_{GE} = \pm 30V$

Electrical Characteristics (Not subject to production test- Verified by design/characterization)

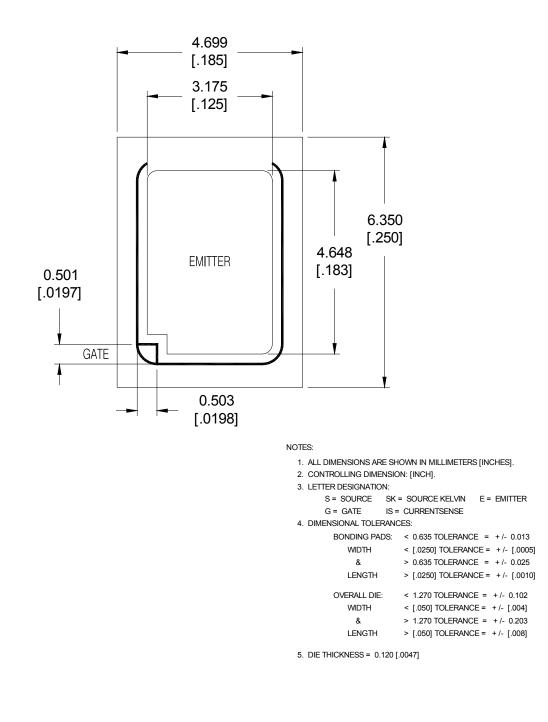
	Parameter	Min.	Тур.	Max.	Units	Conditions
			1.69	2.02		V_{GE} = 15V, I _C = 30A , T _J = 25°C ④
V _{CE(sat)}	Collector-to-Emitter Saturated Voltage		2.07		V	V _{GE} = 15V, I _C = 30A , T _J = 150°C④
						T _J = 150°C, I _C = 120A
RBSOA	Reverse Bias Safe Operating Area	FULL SQUARE				V _{CC} = 960V, Vp ≤1200V
						Rg = 10Ω , V _{GE} = +20V to 0V
C _{iss}	Input Capacitance		3338			V _{GE} = 0V
C _{oss}	Output Capacitance		124		pF	V _{CE} = 30V
C _{rss}	Reverse Transfer Capacitance		75			f = 1.0MHz,
Q _g	Total Gate Charge (turn-on)	—	157	_		I _C = 30A
Q _{ge}	Gate-to-Emitter Charge (turn-on)	_	21	_	nC	V _{GE} = 15V
Q_{gc}	Gate-to-Collector Charge (turn-on)	—	69	—		$V_{CC} = 600V$

Switching Characteristics (Inductive Load-Not subject to production test-Verified by design/characterization)

	Parameter	Min.	Тур.	Max.	Units	Conditions (S)
t _{d(on)}	Turn-On delay time		25	_		I _C = 30A, V _{CC} = 600V
t _r	Rise time		32			R _G = 10Ω, V _{GE} =15V, L=200μH
t _{d(off)}	Turn-Off delay time	_	229			T _J = 25°C
t _f	Fall time		63		20	
t _{d(on)}	Turn-On delay time	_	20		ns	I _C = 30A, V _{CC} = 600V
t _r	Rise time	_	31	_		R _G = 10Ω, V _{GE} =15V, L= 200μH
t _{d(off)}	Turn-Off delay time	_	310			T _J = 175°C
t _f	Fall time		162	_		

IRG7CH42UEF

Die Drawing



REFERENCE: IRG7PH42UD-EPBF IRG7PH42UDPBF

Notes:

①The current in the application is limited by T_{JMax} and the thermal properties of the assembly. $@V_{CC} = 80\% (V_{CES}), V_{GE} = 20V, L = 200\mu H, R_G = 10\Omega.$ ③Refer to AN-1086 for guidelines for measuring $V_{(BR)CES}$ safely ④Die Level Characterization ⑤Values influenced by parasitic L and C in measurement



Additional Testing and Screening

For Customers requiring product supplied as Known Good Die (KGD) or requiring specific die level testing, please contact your local IR Sales.

Shipping

Sawn Wafer on Film. Please contact your local IR sales office for non-standard shipping options

Handling

- Product must be handled only at ESD safe workstations. Standard ESD precautions and safe work environments are as defined in MIL-HDBK-263.
- Product must be handled only in a class 10,000 or better-designated clean room environment.
- Singulated die are not to be handled with tweezers. A vacuum wand with a non-metallic ESD protected tip should be used.

Wafer/Die Storage

- Proper storage conditions are necessary to prevent product contamination and/or degradation after shipment.
- Note: To reduce the risk of contamination or degradation, it is recommended that product not being used in the assembly process be returned to their original containers and resealed with a vacuum seal process.
- Sawn wafers on a film frame are intended for immediate use and have a limited shelf life.

Further Information

For further information please contact your local IR Sales office or email your enquiry to http://die.irf.com

Data and specifications subject to change without notice. This product has been designed and qualified for Industrial market. Qualification Standards can be found on IR's Web site.

International **TOR** Rectifier

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